

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Tomotaka Yokoyama et al.)
)
Serial No.: 10/761,771)
)
Filed: January 20, 2004)
)
For: Management Technique Of Friction)
Coefficient Based On Surface Roughness,)
Substrate For An Information Recording)
Medium, Information Recording Medium)
And Manufacturing Method Thereof)
)
Art Unit: 1773)
)
Confirmation No.: 3525)
)
Examiner: Leszek B. Kiliman)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C (AFTER FINAL)

Sir:

In response to the Final Rejection of August 29, 2006, please enter the following amendment in the above-identified application: